

SLOVENSKI STANDARD SIST EN 62810:2015

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Metoda s valjasto votlino za merjenje kompleksne permitivnosti (dielektrične konstante) nizkoizgubnih dielektričnih palic (IEC 62810:2015)

Cylindrical cavity method to measure the complex permittivity of low-loss dielectric rods (IEC 62810:2015)

Zylindrisches Hohlraumverfahren zur Messung der komplexen Permittivität von verlustarmen dielektrischen Stäben (IEC 62810:2015) REVIEW

Mesure de la permitivité complexe des barreaux diélectriques à faibles pertes par la méthode de la cavité cylindrique (IEC 62810;2015)

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ICS:

33.120.30 Radiofrekvenčni konektorji R.F. connectors (RF)

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en



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Mesure de la permitivité complexe des barreaux diélectriques à faibles pertes par la méthode de la cavité cylindrique (IEC 62810:2015) Zylindrisches Hohlraumverfahren zur Messung der komplexen Permittivität von verlustarmen dielektrischen Stäben (IEC 62810:2015)

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Foreword

The text of document 46F/242/CDV, future edition 1 of IEC 62810, prepared by SC 46F, "R.F. and microwave passive components", of IEC TC 46, "Cables, wires, waveguides, R.F. connectors, R.F. and microwave passive components and accessories" was submitted to the IEC-CENELEC parallel vote and approved by CENELEC as EN 62810:2015.

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•	latest date by which the national	(dow)	2018-03-24
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INTERNATIONAL STANDARD



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INTERNATIONAL ELECTROTECHNICAL COMMISSION

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INTERNATIONAL ELECTROTECHNICAL COMMISSION

CYLINDRICAL CAVITY METHOD TO MEASURE THE COMPLEX PERMITTIVITY OF LOW-LOSS DIELECTRIC RODS

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International Standard IEC 62810 has been prepared by subcommittee 46F: R.F. and microwave passive components, of IEC technical committee 46: Cables, wires, waveguides, R.F. connectors, R.F. and microwave passive components and accessories.

The text of this standard is based on the following documents:

CDV	Report on voting
46F/242/CDV	46F/260/RVC

Full information on the voting for the approval of this standard can be found in the report on voting indicated in the above table.

This publication has been drafted in accordance with the ISO/IEC Directives, Part 2.

The committee has decided that the contents of this publication will remain unchanged until the stability date indicated on the IEC website under "http://webstore.iec.ch" in the data related to the specific publication. At this date, the publication will be

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- reconfirmed,
- withdrawn,
- replaced by a revised edition, or
- amended.

A bilingual version of this publication may be issued at a later date.

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CYLINDRICAL CAVITY METHOD TO MEASURE THE COMPLEX PERMITTIVITY OF LOW-LOSS DIELECTRIC RODS

Scope 1

This International Standard relates to a measurement method for complex permittivity of a dielectric rod at microwave frequency. This method has been developed to evaluate the dielectric properties of low-loss materials in coaxial cables and electronic devices used in microwave systems. It uses the TM_{010} mode in a circular cylindrical cavity and presents accurate measurement results of a dielectric rod sample, where the effect of sample insertion holes is taken into account accurately on the basis of the rigorous electromagnetic analysis.

In comparison with the conventional method described in IEC 60556 [2]¹, this method has the following characteristics:

- the values of the relative permittivity ε' and loss tangent tan δ of a dielectric rod sample can be measured accurately and non-destructively;
- the measurement accuracy is within 1,0 % for ε' and within 20 % for tan δ ;
- the effect of sample insertion holes is corrected using correction charts presented;
- this method is applicable for the measurements on the following condition:
 - frequency:
- 1(GHz ≨/á10 GHz.iteh.ai)
 - relative permittivity: 1 ≦*ε*' ≦100; SIST EN 62810:2015
 - loss tangent: https://standart0.itel≦tan@i≦10antlards/sist/8e61b1b2-0210-481b-

b920-48cc9eac9e53/sist-en-62810-2015

2 Normative references

Void.

3 **Measurement parameters**

The measurement parameters are defined as follows:

$$\varepsilon_{\rm r} = \varepsilon' - j\varepsilon'' \tag{1}$$

$$\tan \delta = \varepsilon''/\varepsilon' \tag{2}$$

where ε' and ε'' are the real and imaginary parts of the complex relative permittivity ε_r .

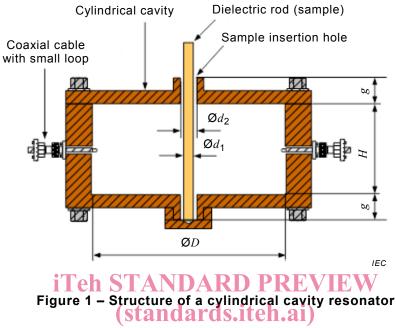
Theory and calculation equations 4

A resonator structure used in these measurements is shown in Figure 1. A cavity, made with copper, with diameter D and height H has sample insertion holes with diameter d_2 and depth g oriented coaxially. A dielectric rod sample of diameter d_1 having ε' and tan δ is inserted into the holes.

¹ Figures in square brackets refer to the Bibliography.

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The TM_{010} mode, where the electric field component in the cavity is parallel to the sample rod, is used for the measurement. Taking account of the effect of sample insertion holes calculated on the basis of the rigorous electromagnetic field analysis, ε' and $\tan \delta$ are determined from the measured values of the resonant frequency f_0 and the unloaded *Q*-factor $Q_{\rm u}$. To avoid the tedious numerical calculation and make the measurements easy, the following process is taken in this measurement:



The following steps shall be taken:

SIST EN 62810:2015 1) At the first step, obtain approximate values r_{e_p} and $tan \delta_{p}$ from the f_0 and Q_u values by using the simple perturbation formulas swhere the reference of sample insertion holes is neglected. The subscript p denotes the calculated values using the following perturbation formulas:

$$\varepsilon_{\rm p} = \frac{1}{\alpha} \frac{f_0 - f_1}{f_1} \left(\frac{D}{d_1} \right)^2 + 1$$
 (3)

$$\tan \delta_{\rm p} = \frac{1}{2\alpha\varepsilon_{\rm p}} \left(\frac{D}{d_{\rm 1}}\right)^2 \left(\frac{1}{Q_{\rm u1}} - \frac{1}{Q_{\rm u0}}\right) \tag{4}$$

where $\alpha = 1/J_1(x_{01})^2 = 1,855$.

 $J_n(x)$ is the Bessel function of order n of first kind and $x_{01} = 2,405$ is the first root of $J_0(x) = 0$. f_0 and Q_{u0} are the resonant frequency and unloaded *Q*-factor measured for the cavity without a sample, respectively. f_1 and Q_{u1} are ones measured for the cavity with a sample.

2) In the second step, obtain accurate values ε' and $\tan \delta$ from ε_p and $\tan \delta_p$ values by using the following equations with correction factors calculated based on the rigorous analysis:

$$\varepsilon' = C_1 \varepsilon_{\mathsf{p}} \tag{5}$$

$$\tan\delta = C_2 \tan\delta_{\rm p} \tag{6}$$

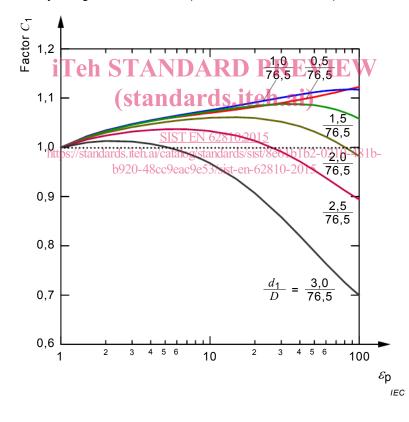
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where correction factors C_1 and C_2 , due to the sample insertion holes and errors included in the perturbation formulas, are calculated numerically by using the Ritz-Galerkin method [3][5], as shown in Figure 2 and Figure 3, and the corresponding data are listed in detail in Table 1, 2, and 3. The missing data of C_1 and C_2 can be obtained by interpolation or extrapolation from the tables. The correction factors shown in these figures are calculated for the cavity with D = 76.5 mm, H = 20.0 mm, $d_2 = 3.0$ mm, and g = 10.0 mm, where the resonant frequency is about 3 GHz. C_1 is also used for a cavity having the same aspect ratios as H/D, d_2/D and g/D.

It is found from the analysis for a cavity with insertion holes which constitute a cut-off TM_{01} mode cylindrical waveguide that f_0 converges to a constant value for g>10 mm and $d_2 = 3$ mm. Therefore, the correction factors shown in Figure 2 and Figure 3 are applicable to a dielectric sample rod with $d_1<3$ mm and ε' below the value calculated by the following equation for the measured value of the resonant frequency:

$$\varepsilon' \le \left(\frac{x_{01}c}{\pi d_2 f_0}\right)^2 \tag{7}$$

where c is the velocity of light in a vacuum ($c = 2.9979 \times 108$ m/s).



Assumptions

D	76,5 mm	d ₂ 3,0 mm
H	20,0 mm	g 10,0 mm

Figure 2 – Correction factor C_1 for ε'